

<b>FORM 1449*</b> <b>INFORMATION DISCLOSURE STATEMENT</b> <b>IN AN APPLICATION</b> (Use several sheets if necessary)	Docket Number: STFD.039PA	Application Number: 10/663,935
	Applicant: EL GAMAL et al.	
	Filing Date: 09/16/2003	Group Art Unit: 2886

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	4,841,348	6/20/1989	Shizukuishi	999	030	
	5,073,029	12/17/1991	Eberly	356	432	
	5,461,425	10/24/1995	Fowler	348	294	
	5,942,775	8/24/1999	Yiannoulos	257	292	
	6,085,576	7/11/2000	Sunshine	073	029.010	
	6,150,189	11/21/2000	Pan	438	059	
	6,150,683	11/21/2000	Merrill	257	292	
	6,518,085	2/11/2003	Wang	438	070	
	6,784,982	8/31/2004	Blumenfeld	356	071	
	7,122,408	10/17/2006	Mouli	438	134	
	7,145,645	12/05/2006	Blumenfeld	356	073	
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Chamberlain, Savvas G., "Photosensitivity and Scanning of Silicon Image Detector Arrays", IEEE Journal of Solid-State Circuits, Vol. SO-4, No. 6, December 1969.				
		Noble, Peter J., "Self-Scanned Silicon Image Detector Arrays", IEEE Transactions on Electron Devices, Vol. Ed. 15, No. 4, April 1968.				

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.	